
OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Application Information**

Application Type:: Regular
Subject Matter:: Utility
CD-ROM or CD-R: None
Title:: METHOD FOR PRODUCING SOI WAFER AND SOI WAFER
Attorney Docket Number:: 118749
Total Drawing Sheets:: 4
Small Entity:: No

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Isao
Family Name:: YOKOKAWA
City of Residence:: Gunma
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Kiyoshi
Family Name:: MITANI
City of Residence:: Gunma
Country of Residence:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	2003-049415	02/26/2003	Yes
Assignee Information			
Assignee Name::		SHIN-ETSU HANDOTAI CO., LTD.	
Street of mailing address::		4-2, Marunouchi 1-chome,	
City of mailing address::		Chiyoda-ku	
State or Province of mailing address::		Tokyo	
Country of mailing address::		Japan	